



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 15, 2025	
IGI Report Number	LG722581152
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MODIFIED DECAGONAL STEP CUT
Measurements	9.29 X 5.86 X 2.91 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	E
Clarity Grade	VS 1

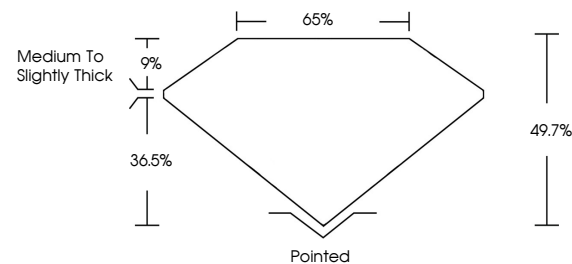
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG722581152

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

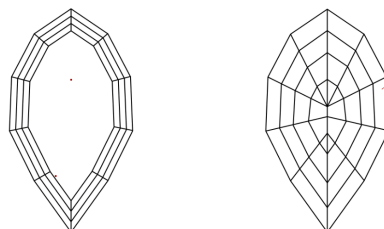
LG722581152
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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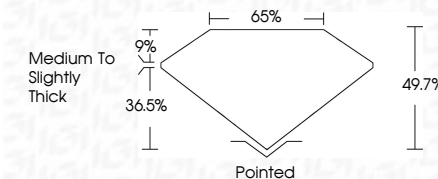
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<p> April 15, 2025 GI Report No. L6772581182 MODIFIED DECAGONAL STEP CUT 29 X 29 X 5.6 X 2.91 MM </p>	<p> 2.01 CARAT E Vs 1 45.7% 65% Medium to Slightly Thick </p>	<p> Polished EXCELLENT EXCELLENT NONE (#61 L6772581182) </p>	<p> Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type Ila </p>
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